

<b>Notice of References Cited</b>	Application/Control No. 10/588,057		Applicant(s)/Patent Under Reexamination NAKANISHI ET AL.	
	Examiner Wen-Tai Lin		Art Unit 2454	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2005/0262209 A1	11-2005	Yu, Tony	709/206
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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